

DEC 22 2005

AP28

TBW 1722/19

AMENDMENT TRANSMITTAL LETTER (Large Entity)

Application of Kozo Nakamura

Docket No.

1110/82821

Application No.

09/856,212

Filing Date

5/18/2001

Examiner

Matthew J. Song

Customer No.

24628

Group Art Unit

1722

Confirmation No.

6761

Invention: **PRODUCTION METHOD FOR SILICON SINGLE CRYSTAL AND PRODUCTION DEVICE FOR SINGLE CRYSTAL INGOT, AND HEAT TREATING METHOD FOR SILICON SINGLE CRYSTAL WAFER**

COMMISSIONER FOR PATENTS:

Transmitted herewith is an amendment in the above-identified application.

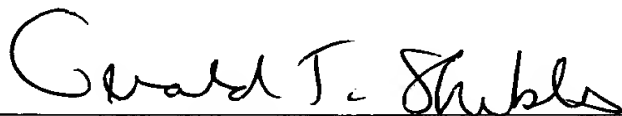
The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	-	20 =	0	x \$50.00	\$0.00
INDEP. CLAIMS	-	3 =	0	x \$200.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00

- ☒ No additional fee is required for amendment.
- ☐ Please charge Deposit Account No. _____ in the amount of _____
- ☐ A check in the amount of _____ to cover the filing fee is enclosed.
- ☒ The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 23-0920
- ☒ Any additional filing fees required under 37 C.F.R. 1.16.
- ☐ Any patent application processing fees under 37 CFR 1.17.
- ☐ Payment by credit card. Form PTO-2038.

WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.



Signature

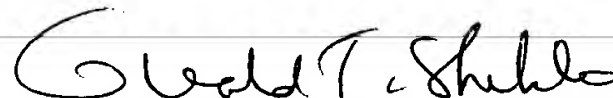
Dated: December 20, 2005

Gerald T. Shekleton
WELSH & KATZ, LTD.
120 South Riverside Plaza
22nd Floor
Chicago, Illinois 60606-3912
Telephone (312) 655-1500
Facsimile (312) 655-1501

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on

December 20, 2005

(Date)



Signature of Person Mailing Correspondence

GERALD T. SHEKLETON, (27,466)

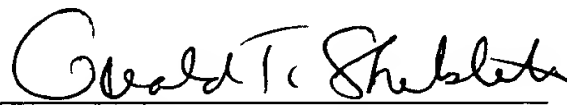
Typed or Printed Name of Person Mailing Correspondence

CC:



PATENT
Attorney Docket No. 1110/82821

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application)	Confirmation No.: 6761
)	
Applicant: Kozo Nakamura, et al.)	
)	<i>I hereby certify that this correspondence is</i>
Serial No.: 09/856,212)	<i>being deposited with the United Postal</i>
)	<i>Service as first class mail in an envelope</i>
Filed: May 18, 2001)	<i>addressed to: Mail Stop AMENDMENT,</i>
)	<i>Commissioner of Patents, P.O. Box 1450,</i>
For: PRODUCTION METHOD)	<i>Alexandria, VA, 22313-1450.</i>
FOR SILICON SINGLE)	
CRYSTAL AND)	<u>December 20, 2005</u>
PRODUCTION DEVICE FOR)	
SINGLE CRYSTAL INGOT,)	
AND HEAT TREATING)	
METHOD FOR SILICON)	
SINGLE CRYSTAL WAFER)	Gerald T. Shekleton Reg. No. 27,466
)	
Examiner: Matthew J. Song)	
)	
Art Unit: 1722)	

AMENDMENT

Mail Stop AMENDMENT
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The Office Action of July 20, 2005 has been carefully reviewed and the following amendments and remarks are made in response thereto.